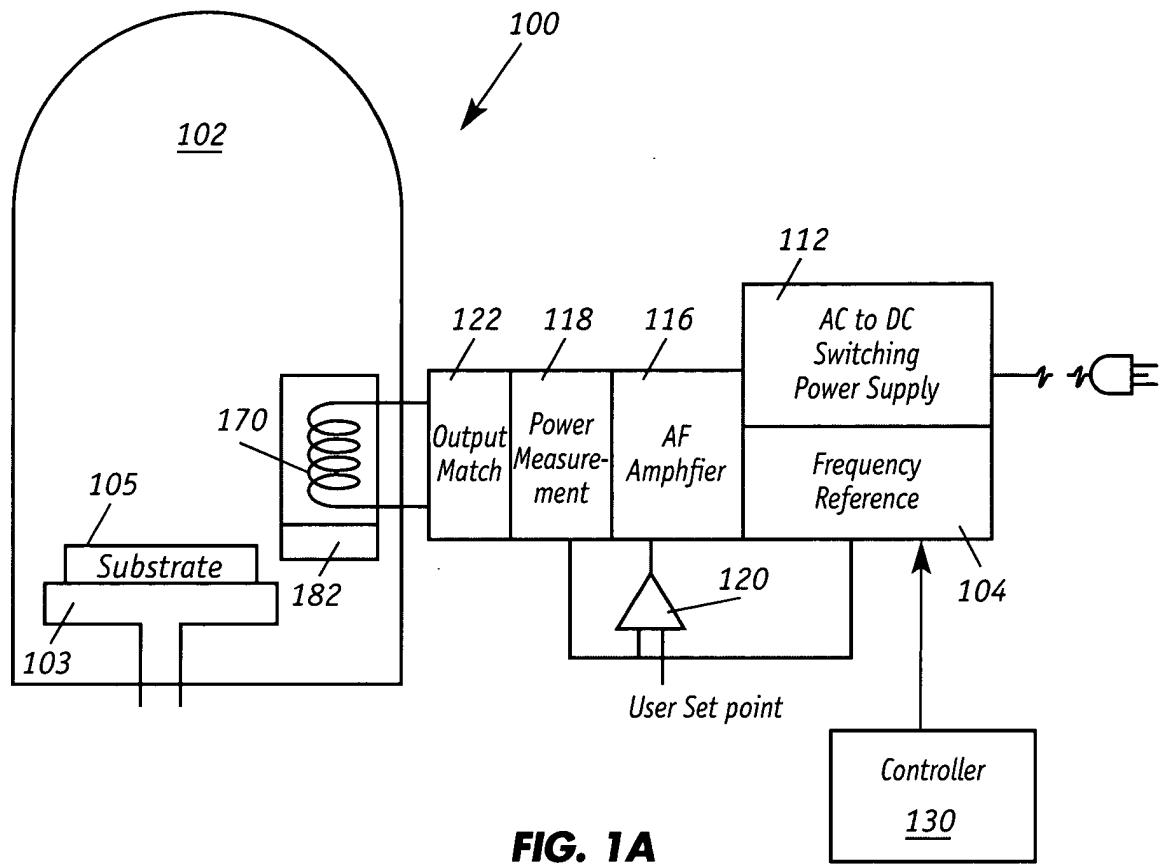




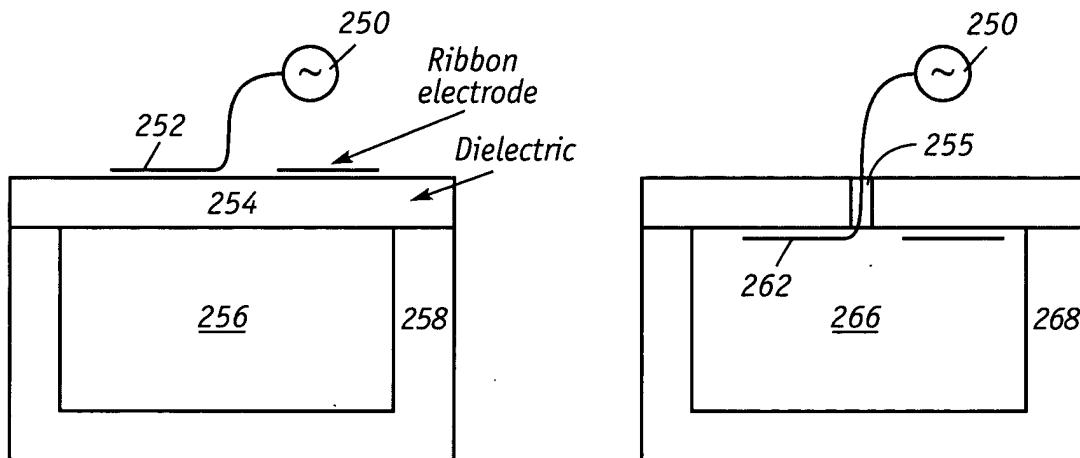
Title: PLASMA SEMICONDUCTOR PROCESSING SYSTEM AND METHOD  
Inventors: Tue Nguyen and Dung Nguyen  
Application No.: 09/898439  
Docket No.: TEGL-01165US0  
Attorney: Charles H. Jew

Filing Date: July 5, 2001  
Art Unit: 2818  
Telephone No. (415) 362-3800

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**FIG. 1A**



**FIG. 1B**

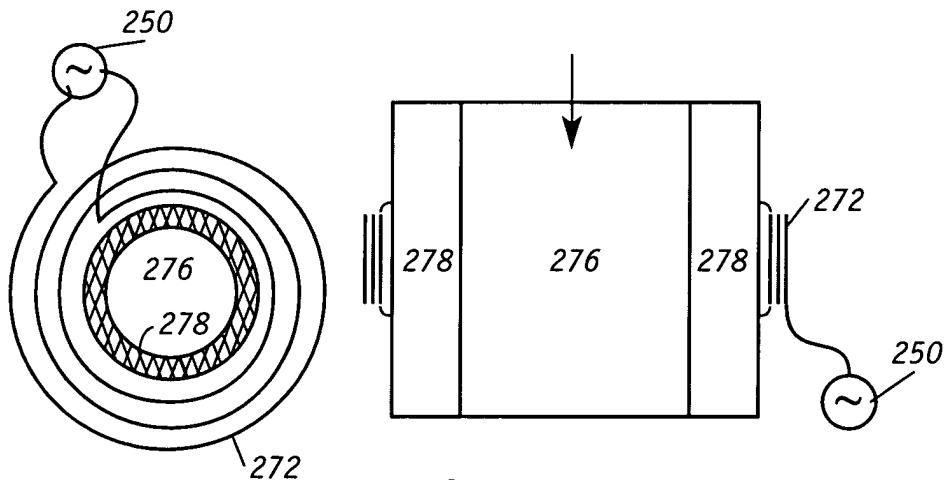
**FIG. 1C**



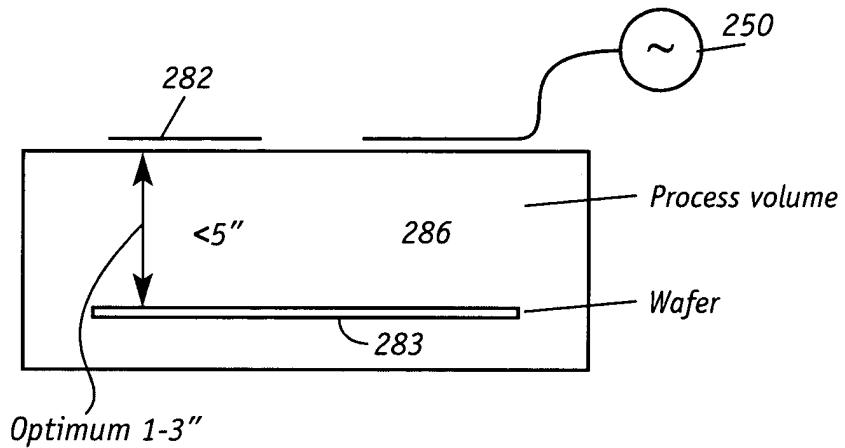
Title: PLASMA SEMICONDUCTOR PROCESSING SYSTEM AND METHOD  
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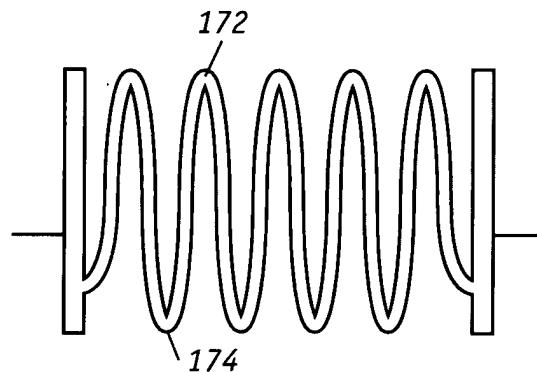
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**FIG. 1D**



**FIG. 1E**



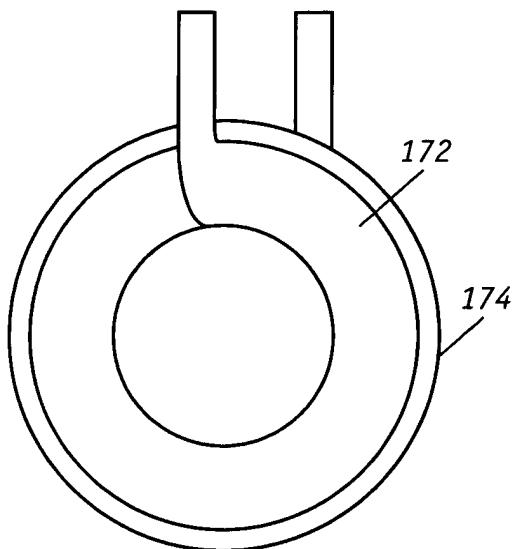
**FIG. 2A**



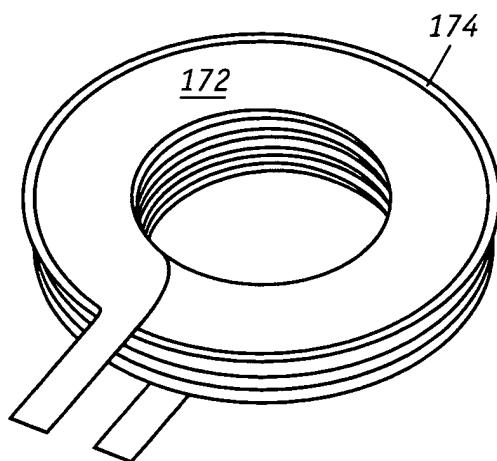
Title: PLASMA SEMICONDUCTOR PROCESSING SYSTEM AND METHOD  
Inventors: Tue Nguyen and Dung Nguyen  
Application No.: 09/898439  
Docket No.: TEGL-0116SUS0  
Attorney: Charles H. Jew

Filing Date: July 5, 2001  
Art Unit: 2818  
Telephone No. (415) 362-3800

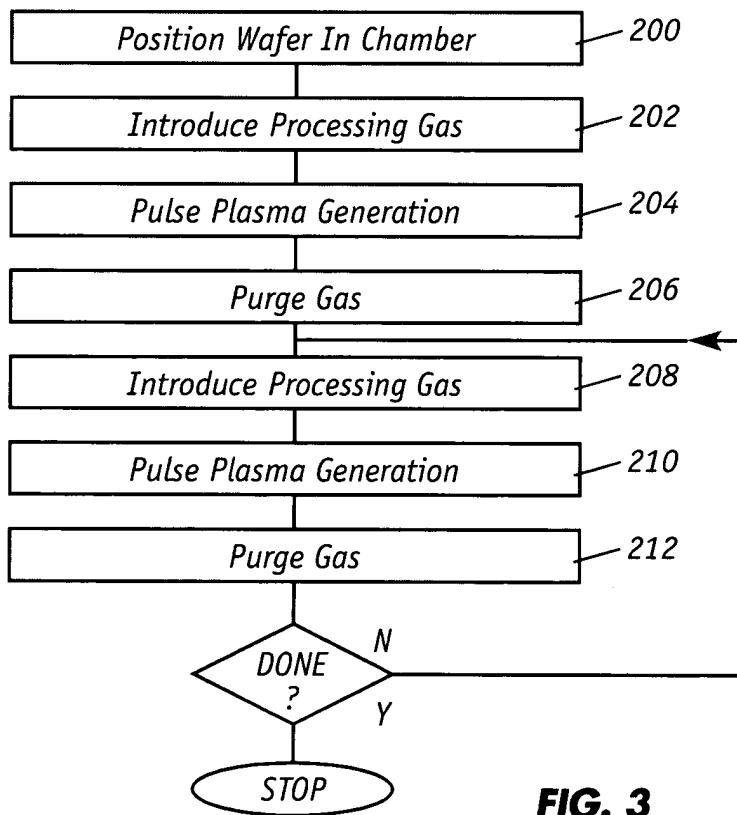
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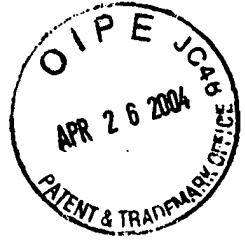
**FIG. 2B**



**FIG. 2C**



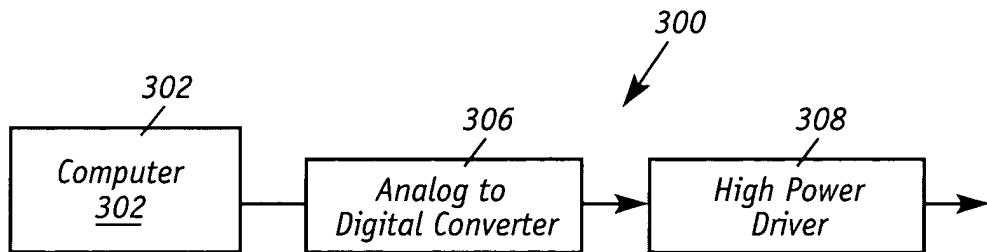
**FIG. 3**



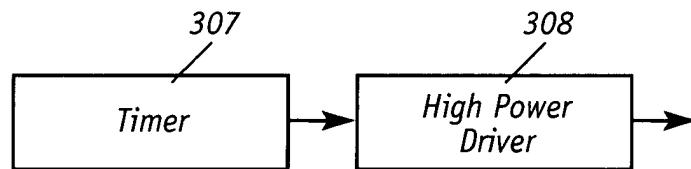
Title: PLASMA SEMICONDUCTOR PROCESSING SYSTEM AND METHOD  
Inventors: Tue Nguyen and Dung Nguyen  
Application No.: 09/898439  
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Attorney: Charles H. Jew

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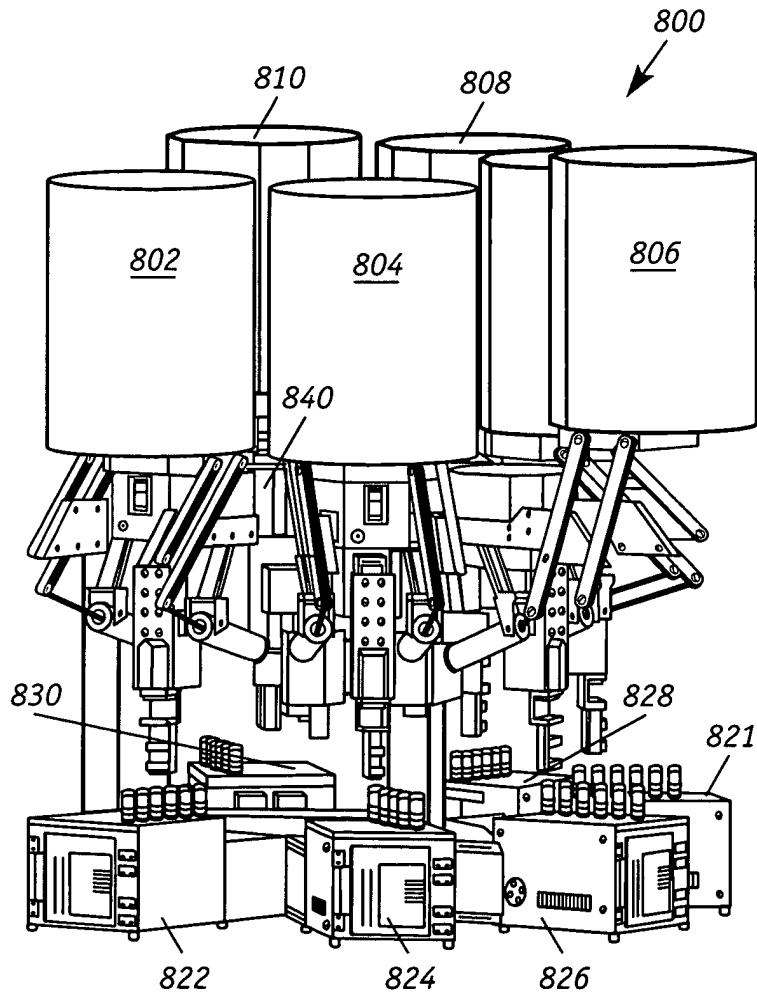
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**FIG. 4A**



**FIG. 4B**



**FIG. 5**

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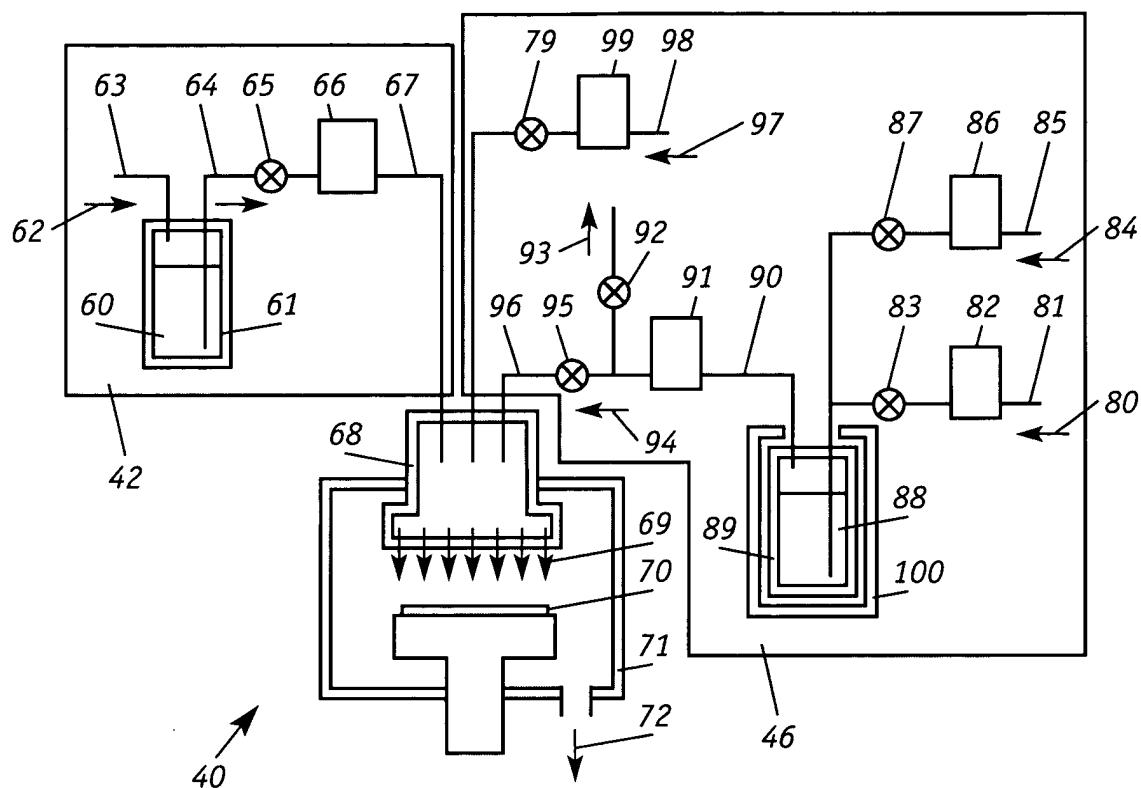


FIG. 6

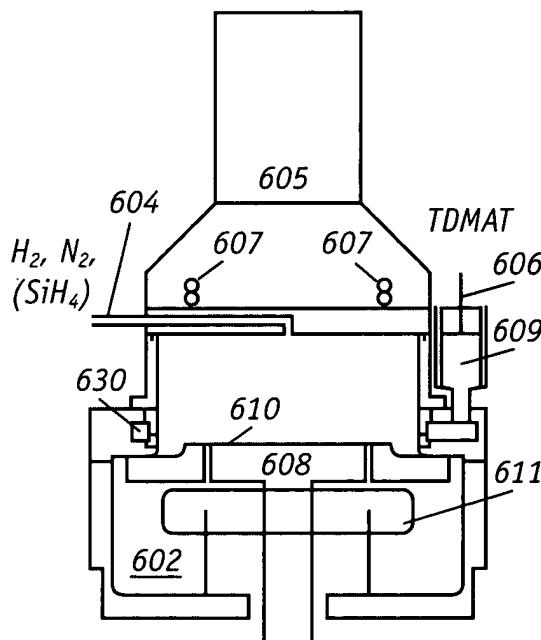


FIG. 7A

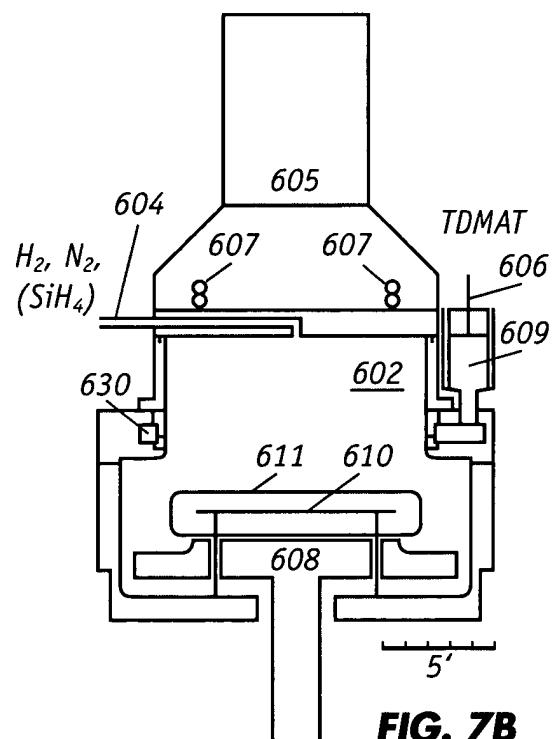


FIG. 7B